

<b>Notice of References Cited</b>	Application/Control No. 10/690,704	Applicant(s)/Patent Under Reexamination SHTEIN ET AL.	
	Examiner David Turocy	Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,788,082	11-1988	Schmitt, Jerome J.	427/248.1
	B	US-6,468,605	10-2002	Shah et al.	427/600
	C	US-5,709,906	01-1998	Bickford et al.	427/306
	D	US-4,869,936	09-1989	Moskowitz et al.	427/455
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kirk-Othmer. "Vacuum Technology". Encyclopedia of Chemical Technology. 4th Edition. Volume 24. 1997. Pages 750-753
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.